

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Jifeng Liu *et al.*

Application No. 10/566,686

Confirmation No. 9220

Filed: January 31, 2006

Art Unit: 1775

For: METHOD AND STRUCTURE OF STRAIN
CONTROL OF SiGe BASED
PHOTODETECTORS AND MODULATORS

Examiner: Not yet assigned

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Pursuant to 37 CFR 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the reference listed on the attached form, based on Form PTO/SB/08. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

Applicants submit herewith a copy of the cited non-patent literature in accordance with 37 CFR 1.98(a)(2).

This Supplemental Information Disclosure Statement is filed before the mailing date of a first Office Action on the merits as far as is known to the undersigned (37 CFR 1.97(b)(3)).

Although no fees are believed due for filing this paper, the Director is hereby authorized to charge any fee which should have been filed herewith to our Deposit Account No. 07-1700, under Order No. MIT-166.

Date: October 3, 2007

Respectfully submitted,

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